

Electronic Acknowledgement Receipt

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Warnings:					
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2	Application Data Sheet	ADSKomatsuElec.pdf	412012	no	4
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Information:					
5	Transmittal letter	NewUtilityPatentApplication.pdf	41043	no	2
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6		PKM050074PCT_SPEC.pdf	5050056	yes	39
	Multipart Description				
	Doc Desc		Start	End	
	Specification		1	34	
	Claims		35	38	
	Abstract		39	39	
Warnings:					
Information:					
7	Transmittal letter	sb0005_fillTransmittalFormInitalFiling.pdf	269460	no	2
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Warnings:					
Information:					
9	Specification - Not in English	InternationalApplicationAsFiledandISR.pdf	1354625	no	29
Warnings:					
Information:					
10	Foreign Reference	WO01_0027600DOC2withAbstractandISR.pdf	1074469	no	29
Warnings:					
Information:					
11	Foreign Reference	2002-98645DOC1.pdf	2446697	no	8
Warnings:					
Information:					
12	Foreign Reference	H11-126736DOC3.pdf	4092155	no	12
Warnings:					
Information:					
13	Foreign Reference	2001-176943DOC4.pdf	849366	no	4
Warnings:					
Information:					
14	Foreign Reference	2002-098645DOC1Abstract.pdf	221097	no	1
Warnings:					
Information:					
15	Foreign Reference	H11-126736DOC3Abstract.pdf	206032	no	1
Warnings:					
Information:					
16	Foreign Reference	2001-176943DOC4Abstract.pdf	155173	no	1
Warnings:					
Information:					

17	Foreign Reference	2002-98645US2002-36771D OC1USCounterpart.pdf	1114214	no	15
Warnings:					
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18	Information Disclosure Statement (IDS) Filed	sb0008a_fillIDS.pdf	491893	no	2
Warnings:					
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